Real-time detection of single electron tunneling using a quantum point contact

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W e observe individual tunnel events of a single electron between a quantum dot and a reservoir, using a nearby quantum point contact (QPC) as a charge meter. The QPC is capacitively coupled to the dot, and the QPC conductance changes by about 1% if the num ber of electrons on the dot changes by one. The QPC is voltage biased and the current is monitored with an IV-convertor at room temperature. We can resolve tunnel events separated by only 8 s, limited by noise from the IV-convertor. Shot noise in the QPC sets a 25 ns lower bound on the accessible timescales.

Fast and sensitive detection of charge has greatly propelled the study of single-electron phenom ena. The most sensitive electrom eter known today is the single-electron transistor (SET) [1], incorporated into a radio-frequency resonant circuit [2]. Such RF-SETs can be used for instance to detect charge uctuations on a quantum dot, capacitively coupled to the SET island [3, 4]. A lready, real-time electron tunneling between a dot and a reservoir has been observed on a sub- s timescale [3].

A much simpler electrom eter is the quantum point contact (QPC). The conductance, G_Q , through the QPC channel is quantized, and at the transitions between quantized conductance plateaus, G_Q is very sensitive to the electrostatic environment, including the number of electrons, N, on a dot in the vicinity [5]. This property has been exploited to measure uctuations in N in real-time, on a timescale from seconds [6] down to about 10 m s [7].

Here we demonstrate that a QPC can be used to detect single-electron charge uctuations in a quantum dot in less than 10 s, and analyze the fundam ental and practical limitations on sensitivity and bandwidth.

The quantum dot and QPC are de ned in the two-dimensional electron gas (2DEG) formed at a GaAs/A $l_{0:27}$ Ga_{0:73}As interface 90 nm below the surface, by applying negative voltages to metal surface gates (Fig. 1a). The device is attached to the mixing chamber of a dilution refrigerator with a base temperature of 20 mK, and the electron temperature is 300 mK in this measurement. The dot is set near the N = 0 to N = 1 transition, with the gate voltages tuned such that the dot is isolated from the QPC drain, and has a small tunnel rate, , to the reservoir. Furthermore, the QPC conductance is set at G_Q = 1=R_Q (30 k)¹, roughly halfway the transition between G_Q = 2e²=h and G_Q = 0, where it is most sensitive to the electrostatic environment [9].

A schem atic of the electrical circuit is shown in Fig.1b. The QPC source and drain are connected to room tem – perature electronics by signal wires, which run through Cu-powder liters at the mixing chamber to block high frequency noise (> 100 M Hz) coming from room tem perature. Each signal wire is twisted with a ground wire from room tem perature to the mixing chamber. A volt-

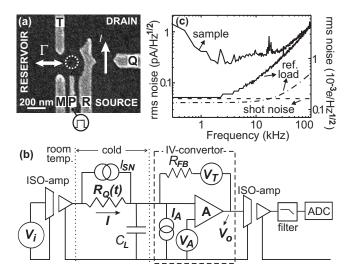


FIG.1: (a) Scanning electron m icrograph of a device as used in the experiment (gates which are grounded are hidden). Gates T; M and R de ne the quantum dot (dotted circle), and gates R and Q form the QPC.Gate P is connected to a pulse source via a coaxial cable. See [8] for a more detailed description. (b) Schem atic of the experim ental set-up, including the most relevant noise sources. The QPC is represented by a resistor, $R_{\,Q}$. (c) Noise spectra measured when the IV -convertor is connected to the sample (top solid trace), and, for reference, to an open-ended 1 m twisted pair of wires (lower solid trace). The latter represents a 300 pF load, if we include the 200 pF m easured am pli er input capacitance. The diagram also shows the calculated noise level for the 300 pF reference load, neglecting I_A (dotted-dashed), and the shot noise lim it (dashed). The left and right axes express the noise in terms of current through the QPC and electron charge on the dot respectively.

age, V_i, is applied to the source via a hom e-built optocoupled isolation stage. The current through the QPC, I, is measured via an IV-convertor connected to the drain, and an opto-coupled isolation amplier, both hom e-built as well. The IV-convertor is based on a dual low-noise JFET (Interfet 3602). Finally, the signal is AC-coupled to an 8th-order elliptic low-pass liter (SR S650), and the current uctuations, I, are digitized at 2.2 10° 14-bit sam ples per second (AD w in G old).

The measurement bandwidth is limited by the lowpass liter formed by the capacitance of the line and Cu-

noise	m s noise	current	m s chạrge noise
source	n expression	A/ ^P Hz	e/ ^r Hz
I _{SN}	р <u>Т (1</u> Т)2еІ	49 10 ¹⁵	1 : 6 10 ⁴
VT	$\frac{P}{4k_B T = R_{FB}}$	41 10 ¹⁵	1 : 4 10 ⁴
VA	$V_A \frac{1+j2 f_{R_Q} C_L}{R_Q}$		
V_{A} , low f	V _A =R _{FB}	32 10 ¹⁵	1:1 10 ⁴
V_A , high f	$V_{\rm A}2$ fC $_{\rm L}$	7:5 10 ¹⁸ f	2 : 5 10 ⁸ f
I_{A}	IA	-	-

TABLE I: Contributions to the noise current at the IVconvertor input. By dividing the noise current by 300 pA (the signal corresponding to one electron charge leaving the dot), we obtain the rm s charge noise on the dot.

powder lters, C_L 1.5 nF, and the input in pedance of the IV-convertor, $R_i = R_{FB} = A$. Thermal noise considerations (below) in pose $R_{FB} = 10M$. We choose the ampli er gain A = 10000, such that $1 = (2 R_i C_L)$ 100 kH z [10]. However, we shall see that the true limitation to measurement speed is not the bandwidth but the signal-to-noise ratio as a function of frequency.

The m easured signal corresponding to a single electron charge leaving the dot am ounts to ~I~~0.3~nA with the QPC biased at V_i = 1 mV, a 1% change in the overall current I (I~~30~nA, consistent with the series resistance of $R_{\rm Q}$, $R_{\rm i}$ = 1 k~~and the resistance of the 0 hm ic contacts of about 2 k~~). Naturally, the signal strength is proportional to V_i , but we found that for $V_i~~1~mV$, the dot occupation was a ected, possibly due to heating. We therefore proceed with the analysis using I = 30 nA and ~I = 0.3~nA.

The most relevant noise sources [11] are indicated in the schematic of Fig. 1b. In Table I, we give an expression and value for each noise contribution in term s of rm s current at the IV -convertor input, so it can be com pared directly to the signal, I. W e also give the corresponding value for the rms charge noise on the quantum dot. Shot noise, I_{SN} , is intrinsic to the QPC and therefore unavoidable. Both I_{SN} and I are zero at QPC transm ission T = 0 or T = 1, and m axim alat T = 1=2; here 1=2. The e ect of therm alnoise, $V_{\rm T}$, can be weuseT kept sm all com pared to other noise sources by choosing R_{FB} su ciently large; here $R_{FB} = 10 M$. The JFET input voltage noise is measured to be $V_A = 0.8 \text{ nV} / \text{Hz}$. As a result of $V_{\rm A}$, a noise current $\,$ ows from the IV- $\,$ convertor input leg to ground, through the QPC in parallel with the line capacitance. Due to the capacitance, $C_{\,\rm L}$, the rm s noise current resulting from $V_{\rm A}$ increases with frequency; it equals I at 120 kHz. There is no speci cation available for the JFET input current noise, I_A , but for comparable JFETs, I_A is a few fA / Hz at 1 kHz.

W e sum marize the expected noise spectrum in Fig.1c, and compare this with the measured noise spectrum in the same gure. For a capacitive reference load $C_L = 300$ pF, the noise level measured below a few kHz is 52

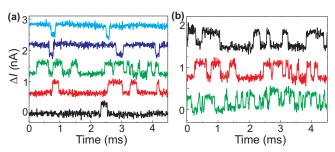


FIG.2: M easured changes in the QPC current, I, with the electrochem ical potential in the dot and in the reservoir nearly equal. I is \high" and \low " for 0 and 1 electrons on the dot respectively ($V_i = 1 \text{ m V}$; the steps in I are 0.3 nA). Traces are 0 set for clarity. (a) The dot potential is low ered from top to bottom. (b) The tunnel barrier is low ered from top to bottom.

 $fA \space{2mu} \$

From the data, we nd that the measured charge noise integrated from DC is about three times smaller than e at 40 kH z. W e set the cut-o frequency of the external low-pass lter at 40 kH z, so we should see clear steps in time traces of the QPC current, corresponding to single electrons tunneling on or o the dot.

W e test this experim entally, in the regim e where the electrochem ical potential in the dot is nearly lined up with the electrochem ical potential in the reservoir. The electron can then spontaneously tunnel back and forth between the dot and the reservoir, and the QPC current should exhibit a random telegraph signal (RTS). This is indeed what we observe experim entally (Fig. 2). In order to ascertain that the RTS really originates from electron tunnel events between the dot and the reservoir, we verify that (1) the dot potential relative to the Ferm i level determ ines the fraction of the time an electron resides in the dot (Fig. 2a) and (2) the dot-reservoir tunnel barrier sets the RTS frequency (Fig. 2b). The m s baseline noise 0:05 nA and the shortest steps that clearly reach is above the noise level are about 8 s long. This is consistent with the 40 kH z lter frequency, which permits a risetime of 8 s.

Next, we induce tunnel events by pulsing the dot potential, so N predictably changes from 0 to 1 and back to 0. The response of the QPC current to such a pulse contains two contributions (Fig. 3a). First, the shape of the pulse is rejected in I, as the pulse gate couples

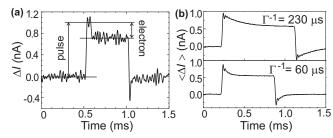


FIG.3: (a) M easured changes in the QPC current, I, when a pulse is applied to gate P, near the degeneracy point between 0 and 1 electrons on the dot ($V_1 = 1 \text{ m V}$). (b) A verage of 286 traces as in (a). The top and bottom panel are taken with a di erent setting of gate M. The dam ped oscillation following the pulse edges is due to the 8th-order 40 kH z lter.

capacitively to the QPC. Second, some time after the pulse is started, an electron tunnels into the dot and I goes down by about 0.3 nA. Sim ilarly, I goes up by 0.3 nA when an electron leaves the dot, some time after the pulse ends. We observe that the time before tunneling takes place is random by distributed, and obtain a histogram of this time simply by averaging over many single-shot traces (Fig. 3b). The measured distribution decays exponentially with the tunnel time, characteristic of a Poisson process. The average time before tunneling corresponds to 1^{1} , and can be tuned by adjusting the tunnel barrier.

O ur m easurem ents clearly dem onstrate that a QPC can serve as a fast and sensitive charge detector. Com – pared to an SET, a QPC o ers several practical advantages. First, a QPC requires fabrication and tuning of just a single additional gate when integrated with a quantum dot de ned by m etal gates, whereas an SET requires two tunnel barriers, and a gate to set the island potential. Second, QPCs are more robust and easy to use in the sense that spurious, bw-frequency uctuations of the electrostatic potential hardly change the QPC sensitivity to charges on the dot (the transition between quantized conductance plateaus has an alm ost constant slope over a wide range of electrostatic potential), but can easily spoil the SET sensitivity.

W ith an RF-SET, a sensitivity to charges on a quantum dot of 2 10 $^{4}e^{-}$ Hz has been reached over a 1 M Hz bandwidth [3]. Theoretically even a ten times better sensitivity is possible [2]. Could a QPC perform equally well?

The noise level in the present m easurement could be reduced by a factor of two to three using a JFET inputstage which better balances input voltage noise and input current noise. Further im provements can be obtained by lowering C_L , either by reducing the liter capacitance, or by placing the IV-convertor closer to the sample, inside the refrigerator. The bandwidth would also increase as it is inversely proportional to C_L .

M uch m ore signi cant reductions in the instrum entation noise could be realized by embedding the QPC in a resonant electrical circuit and m easuring the dam ping of the resonator, analogous to the operation of an RF-SET.We estimate that with an RF-QPC and a low-temperature HEMT amplier, the sensitivity could be 2 10 ⁴e⁻ Hz. At this point, the noise current from the amplier circuitry is comparable to the QPC shot noise. Furthermore, the bandwidth does not depend on C_L in rejection measurements, and can easily be 1 M Hz.

To what extent the signal can be increased is unclear, as we do not yet understand the mechanism through which the dot occupancy is disturbed for $V_i > 1 \text{ m V } [13]$. Certainly, the capacitive coupling of the dot to the QPC channel can easily be made ve times larger than it is now by optimizing the gate design [6]. Keeping $V_i = 1 \text{ m V}$, the sensitivity would then be 4 $10^{5} \text{e}^{-1} \text{ Hz}$.

Finally, we point out that, unlike a SET, a QPC can reach the quantum lim it of detection [12], where the measurement induced decoherence takes the minimum value permitted by quantum mechanics. Qualitatively, this is because (1) information on the charge state of the dot is transferred only to the QPC current and not to degrees of freedom which are not observed, and (2) an external perturbation in the QPC current does not couple back to the charge state of the dot.

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